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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Joyner et al.

Docket No.: TI-29912

Serial No:

**TBD** 

Examiner: TBD

Filed:

02/05/02

Art Unit:

**TBD** 

For:

METHOD FOR MANUFACTURING AND STRUCTURE FOR

TRANSISTORS WITH REDUCED GATE TO CONTACT SPACING

## PRELIMINARY AMENDMENT

February 5, 2002

Assistant Commissioner for Patents

Washington, DC 20231

Dear Sir:

Please amend the above referenced application as follows:

In the Specification:

Page 1, before line 1, insert -- This application claims priority under 35 USC § 119(e)(1) of provisional application numbers 60/266,899 filed 02/06/01.--

## **REMARKS**

Entry of the foregoing amendment prior to examination is respectfully requested.

If the Examiner has any questions or other correspondence regarding this application, Applicant requests that the Examiner contact Applicant's attorney at the below listed telephone number and address.

Respectfully submitted,

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